

K-1984

Applicant

: Yasumi Sago et al.

Title

: ELECRO-STATIC CHUCKING MECHANISM AND

SURFACE PROCESSING APPARATUS

Serial No.

: 09/879,934

Filed : June 14, 2001

Group Art Unit: 1763

Examiner : Ram N. Kackar

Hon. Commissioner of Patents

P.O. Box 1450, Alexandria, VA 22313-1450

October 4, 2004

AMENDMENT

Sir:

In response to the communication of April 2, 2004, please amend the application, as follows:

Amendments to the Claims Remarks